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PATENT & TRADEMARK OFFICE

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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:
Judy H. Huang

Serial No.: 09/270,039

Confirmation No.: 1949

Filed: March 16, 1999

For: In Situ Deposition of a Low K Layer, Barrier Layer, Etch Stop and Anti-Reflective Coating for Damascene Application

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§ Group Art Unit: 2823
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§ Examiner: George R. Fourson, III
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Dear Sir:

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37 CFR 1.8
I hereby certify that this correspondence is being deposited on 10/22, 2004 with the United States Postal Service as First Class Mail in an envelope addressed to: Mail Stop AF Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

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STATEMENT OF COMMON OWNERSHIP

The present application (Serial No. 09/270,039; hereinafter the "Application"), and. Patent No. 6,287,990, *Cheung*, were, at the time the invention of the Application was made, owned by the same person, or subject to an obligation of assignment to the same person, Applied Materials, Inc.

Respectfully submitted,

[signature]

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